Application/Control No. Applicant(s)/Patent Under Reexamination 10/589,544 CHANG ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 1655 Qiuwen Mi **U.S. PATENT DOCUMENTS Document Number** Date Classification Name Country Code-Number-Kind Code MM-YYYY US-2004/0208863 10-2004 Versalovic et al. 424/115 Α US-2005/0180962 08-2005 Raz et al. 424/093.45 В С US-1,459,395 06-1923 TONI HAMBURGER 435/139 US-D US-Ε US-F US-G US-Н US-US-US-Κ US-L US-М FOREIGN PATENT DOCUMENTS **Document Number** Date Classification Country -Name Country Code-Number-Kind Code MM-YYYY JP 2000236873 01-1999 Ν Japan ------0 Р Q R s Т **NON-PATENT DOCUMENTS**

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